

00862.022435.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



re Application of:

KIYOSHI ARAKAWA

Appln. No.: 10/622,143

Filed: July 18, 2003

For: EXPOSURE APPARATUS,  
MAINTENANCE METHOD  
THEREFOR, SEMICONDUCTOR  
DEVICE MANUFACTURING  
METHOD USING THE APPARATUS,  
AND SEMICONDUCTOR  
MANUFACTURING FACTORY

Examiner: H. Nguyen

Group Art Unit: 2851

November 3, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

REMARKS

WO 99/50892 and JP-A-8-279459 were cited in a Korean Official Action of a counterpart foreign application corresponding to the above-referenced application. The Official Action is dated September 17, 2003. A copy of the Official Action is enclosed. Applicant respectfully submits that the WO document corresponds to EP 1 075 017 A1,

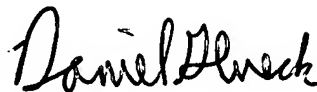
and the JP document corresponds to U.S. Patent No. 6,341,006. An Abstract for the JP document was obtained from a commercial database and is also enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

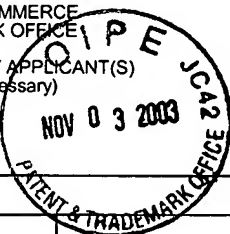


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DC\_MAIN 148132 v 1

FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)  Submitted: November 3, 2003			ATTY DOCKET NO. <b>00862.022435.1</b>		APPLICATION NO. <b>10/622,143</b>		
			APPLICANT <b>KIYOSHI ARAKAWA</b>				
			FILING DATE <b>July 18, 2003</b>		GROUP <b>2851</b>		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		<b>6,341,006 B1</b>	<b>01/22/02</b>	<b>Murayama, et al.</b>	<b>355</b>	<b>53</b>	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		<b>WO 99/50892</b>	<b>10/07/99</b>	<b>PCT</b>			<b>Abstract</b>
		<b>1 075 017 A1</b>	<b>7/02/01</b>	<b>Europe</b>			
		<b>8-279459</b>	<b>10/22/96</b>	<b>Japan</b>			<b>Abstract</b>
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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